

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE RECEIVED

TECHRULGGY CENTER 2800

In re the Application of:

NAKAJYO, Shinsuke et al.

Serial Number: 09/686,958

Filed: October 12, 2000

Examiner: Michael K. Luhrs

Group Art Unit:, 2824

P.T.O. Confirmation No.: 5708

MANUFACTURE OF WAFER LEVEL SEMICONDUCTOR DEVICE AND For.

SEMICONDUCTOR DEVICE

POWER TO FILE CORRECTED FORMAL DRAWINGS

Commissioner for Patents Washington, D.C. 20031

Date: November 26,200

Sir:

The undersigned, attorney of record in the above-identified application, hereby instructs Frankie Locklear and Element Patent Drafting, to correct the drawings, as required and approved in such above-identified application and to file such corrected formal drawings in the United States Patent and Trademark Office in such application.

In the event that this paper and such formal drawings are not timely filed, Applicants respectfully petition for an appropriate extension of time. The fees for such an extension or any other fee which may be due with respect to this paper, may be charged to Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Donald W. Hanson Attorney for Applicant

Reg. No. 27,133

DWH/nk Atty. Docket No. **001344** Suite 1000, 1725 K Street, N.W. Washington, D.C. 20006 (202) 659-2930

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